Atomic layer deposition reactor for fixed-bed powder processing with inert sample transfer

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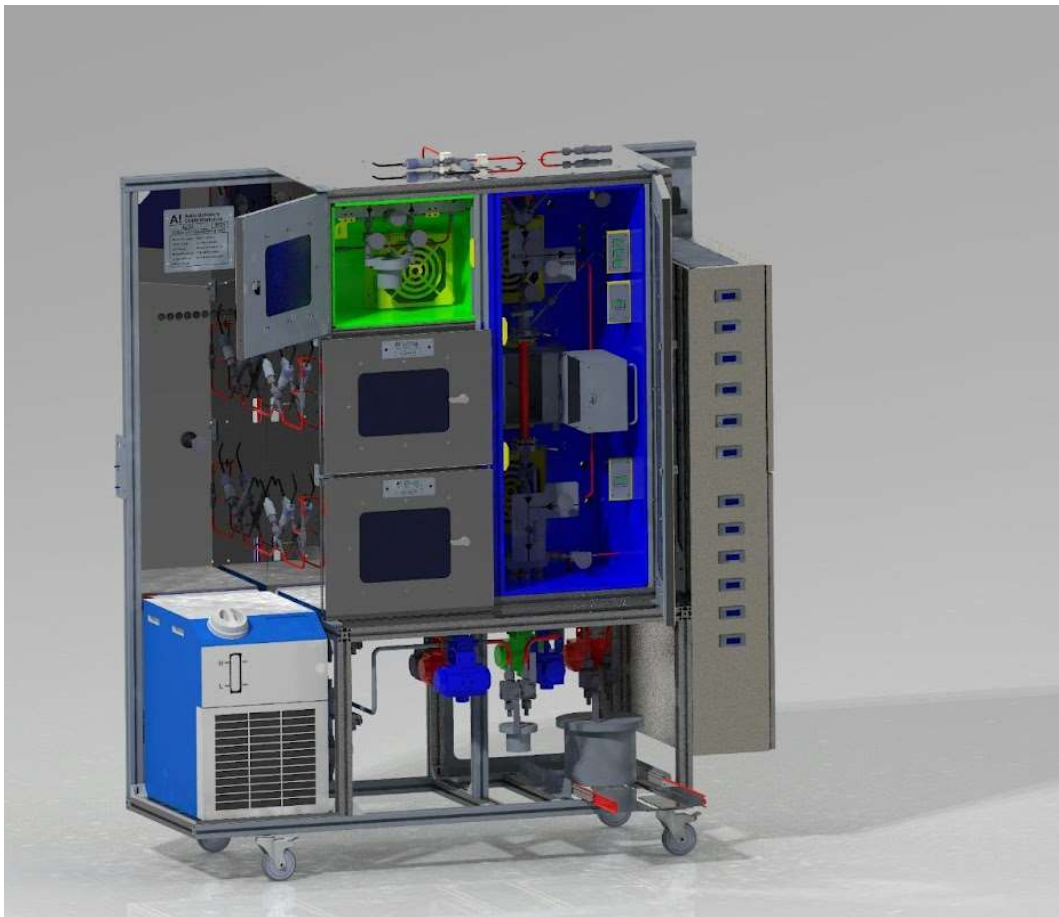[d] Aalto University, School of Chemical Engineering, Department of Chemistry and Materials Science, Espoo, Finland

Figure 1. 3D model of the new particle ALD reactor.